

01-10-05

IFW #



Docket No. 1232-5145

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Oishi

Group Art Unit: 2851

Serial No.: 10/659,194

Examiner: Nguyen

Filed: September 9, 2003

For: METHOD AND SYSTEM FOR OPTIMIZING PARAMETER VALUE IN
EXPOSURE APPARATUS, AND EXPOSURE APPARATUS AND METHOD

AMENDMENT

Mail Stop AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Responsive to the Office Action mailed September 7, 2004, the Applicant respectfully requests reconsideration in view of the following amendments and remarks. A petition and fee for a one month extension of time is submitted herewith. No additional fees are believed due in connection with this response. However, in the event any additional fees are necessitated by this response, the Commissioner is hereby authorized to charge our deposit account no. 13-4500, order no. 1232-5145.

Amendments to the Claims begin on page 2

Remarks begin on page 8